In the Claims:

This listing of claims replaces all prior versions, and listings, of claims in the application.

- 1. (Currently Amended) A semiconductor laser device, comprising:
 - a semiconductor laser element;
- a generally circular stem to which said semiconductor laser element is mounted, said stem having at least one notch at an outer peripheral part thereof; and
- a cap covering said semiconductor laser element, said cap having a flange for welding to an upper surface of the stem, wherein

said flange of the cap is provided with at least one cut-off portion; and when said cap is in a state welded to the stem, at least one said or each cut-off portion of the flange is positioned in a region of the stem in which no notch is present.

- 2. (Original) The semiconductor laser device according to claim 1, wherein the number of notches provided at the outer peripheral part of the stem and the number of cut-off portions of the flange are three or more.
- 3. (Original) The semiconductor laser device according to claim 1, wherein a difference between a radius of the circular stem and that of the flange is 0.4 mm or less.
- 4. (Original) The semiconductor laser device according to claim 1, wherein a venthole is provided in a side surface of the cap at a location corresponding to said cut-off portion.
- 5. (Currently Amended) A method for producing the semiconductor laser device of claim 1, wherein when comprising welding a flange of a cap, which is provided with said at least one cut-off portion, to an upper surface of a generally circular stem having at least one notch at an outer peripheral part thereof, the method comprises and, when welding the flange:

positioning the stem using said at least one notch of the stem; and positioning the cap using said at least one cut-off portion of the flange of the cap such that at least one said or each cut-off portion is located in a region having no notch of the stem.

6. (Original) The method according to claim 5, wherein said flange has a plurality of cut-off portions, and partial flange portions into which the flange is divided by these cut-off portions are welded to the stem by independent electrodes and power supplies.